

Introduction to Nanophysics

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What is the size for a “nano” ?

One (nm) equals to 1/1000000000 (10⁻⁹) meter

10⁻³ m , **Macro**

10⁻⁶ m , **Micro**

10⁻⁹ m , **Meso**

R. Feynmann Already Knew about this !

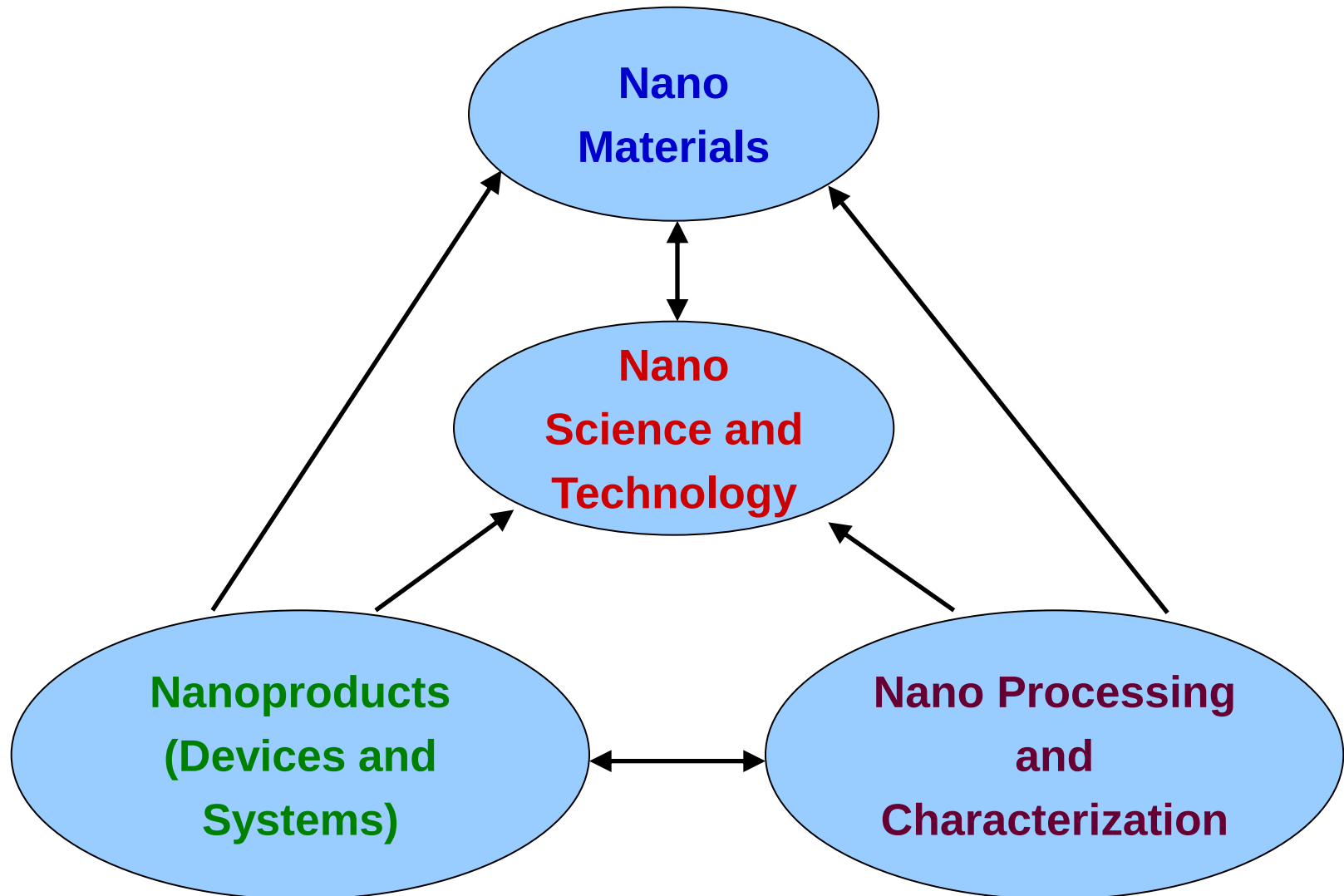


**“ There’s plenty of
room at the bottom ! ”
in 1959.**

Physicists noticed the “Nano” as early as

- 4th Century, Roman glassmaker: the color of glasses can be changed by mixing in metal particles
- In 1883, Films containing silver halides for photography were invented by George Eastman, founder of Kodak.
- 1908, Gustav Mie first provided the explanation of the size dependence of color.
- Vision from Feynman in 1959: “There is plenty room at the bottom”, and also recognized there are plenty of nature-given nanostructures in biological systems.
- 1950-1960, small metal particles were investigated by physicists.
- 1957, Ralph Landauer realized the importance of quantum mechanics plays in devices with small scales.
- Before 1997 => **mesoscopic** (or low dimensional) physics : quantum dots, wells, wires.....are known already.

Major Topics of Nanoscience and Technology



What is the Nano Technology?

➤ Science and Technology Down scaling to size under 100 nm:

Via “Top-down” lithographic patterning:

-- Moore’s law !

➤ Manipulate the atomic and molecular structures:

“Bottom-up” nano materials, growth and assembly.

Feymann: There’s plenty of room at the bottom

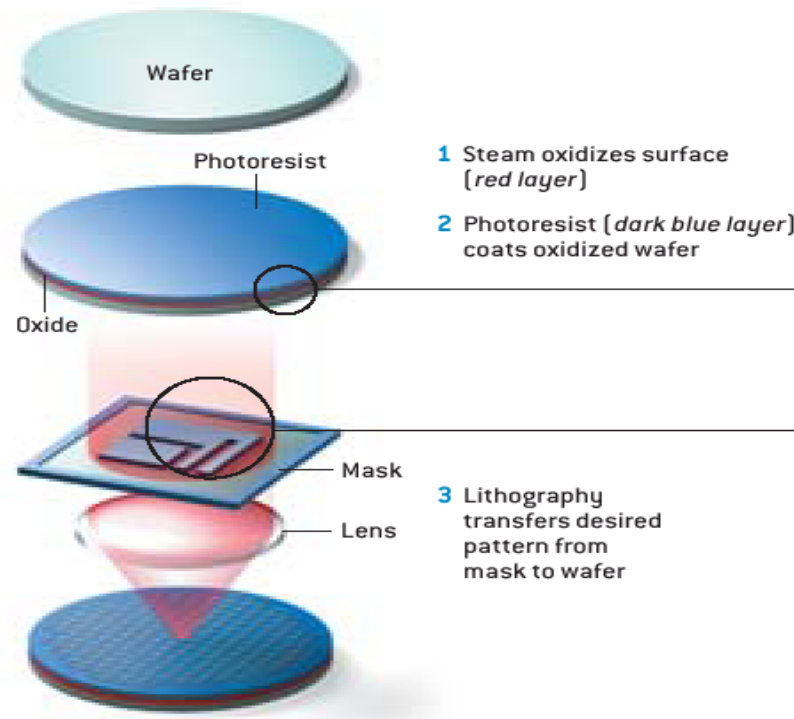
Major Driving Force pushing for Nano Technology: Due to the bottle neck in Microelectronics

Moore's Law :

A 30% decrease in the size of printed dimensions in every two years.

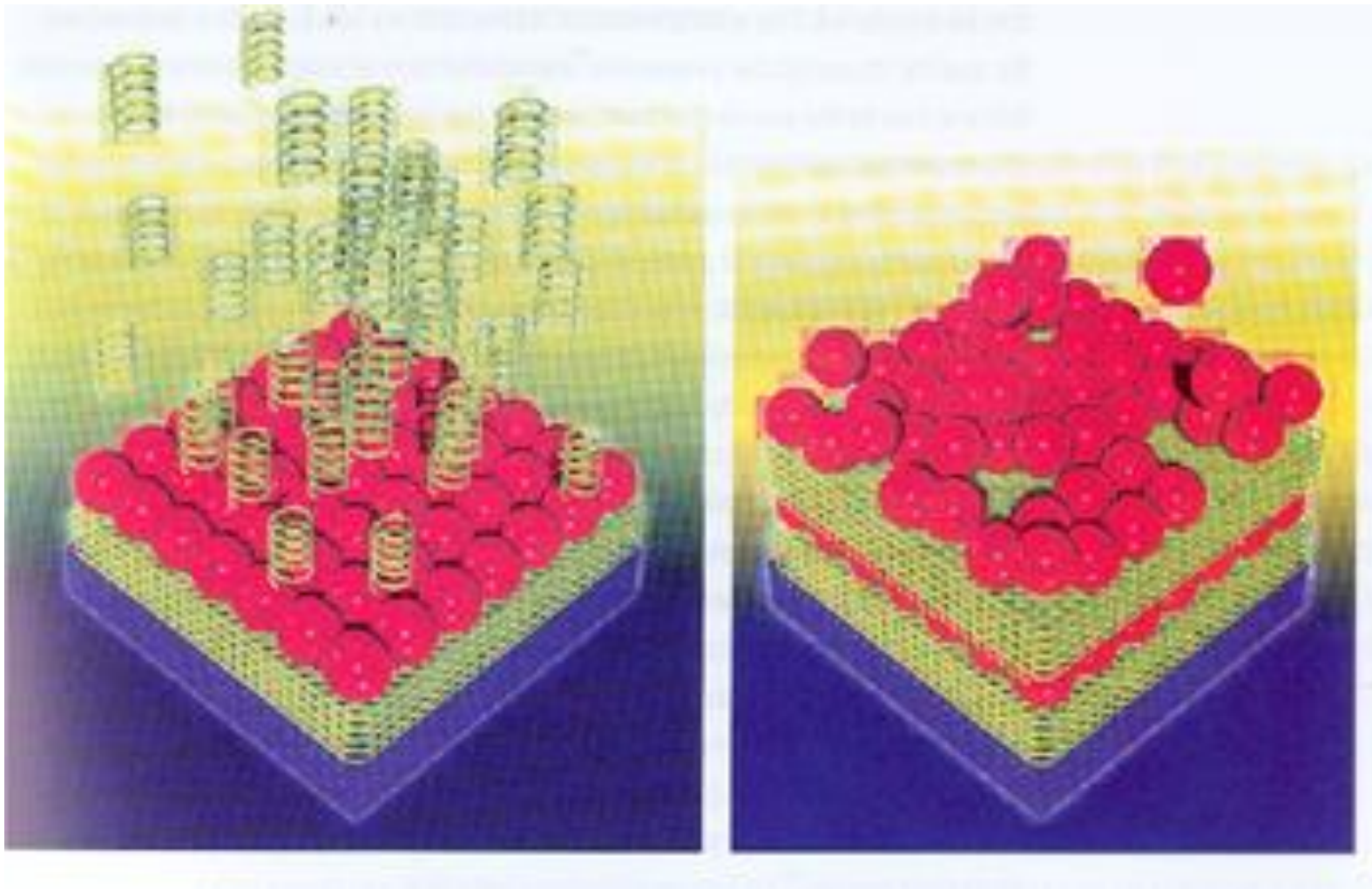


BASIC CHIPMAKING PROCESS



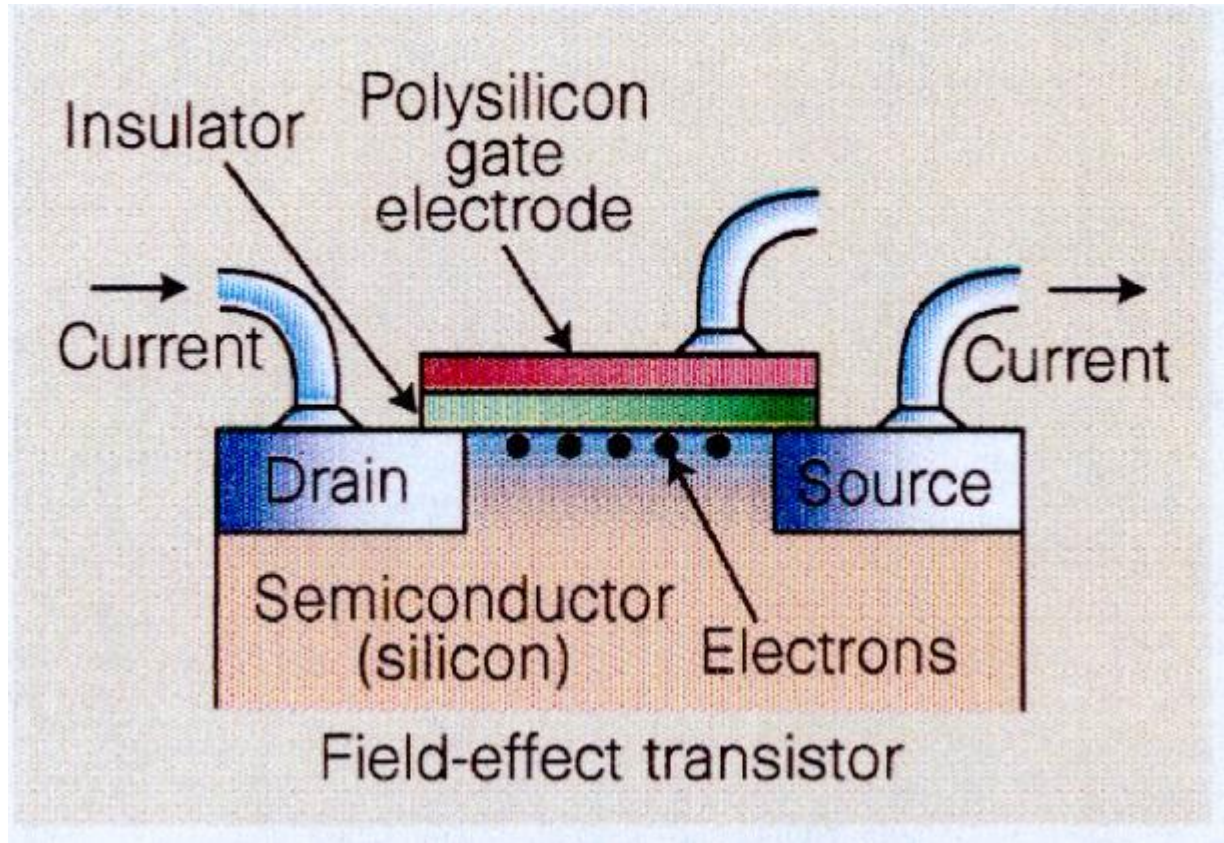
Bottom-up Nano systems & Self-Assembly

enabling of designing large molecules and nano materials



***Two basic modern electronic technologies
in Condensed Matter Physics Field***

Metal-Oxide-Field Effect Transistor

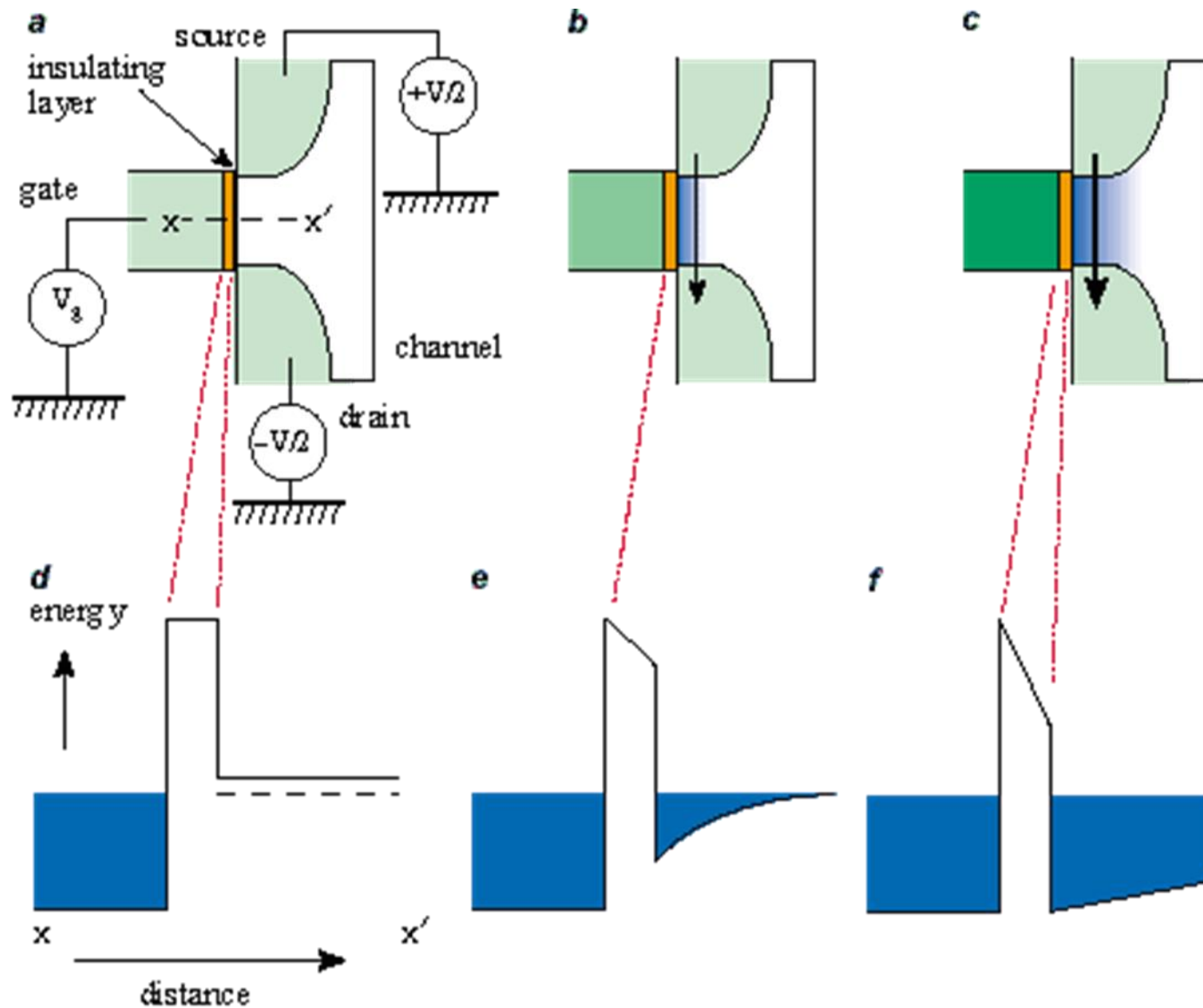


1960 Kahng and Atalla, First MOSFET

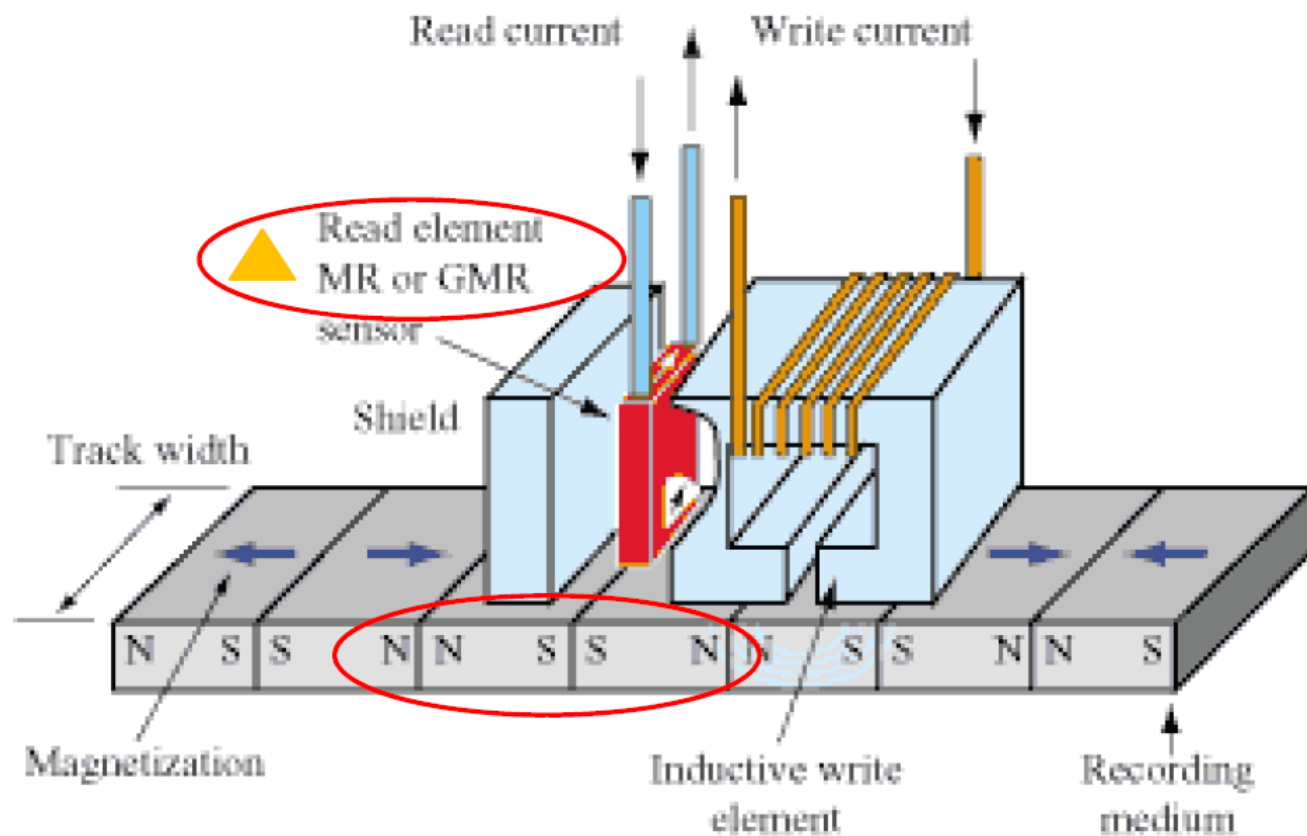
1970 First IC, 1 kbit, 750 khz microprocessor

電子科技之基礎--MOSFET

(metal-oxide-semiconductor field-effect transistor)



電子科技之基礎--磁記錄

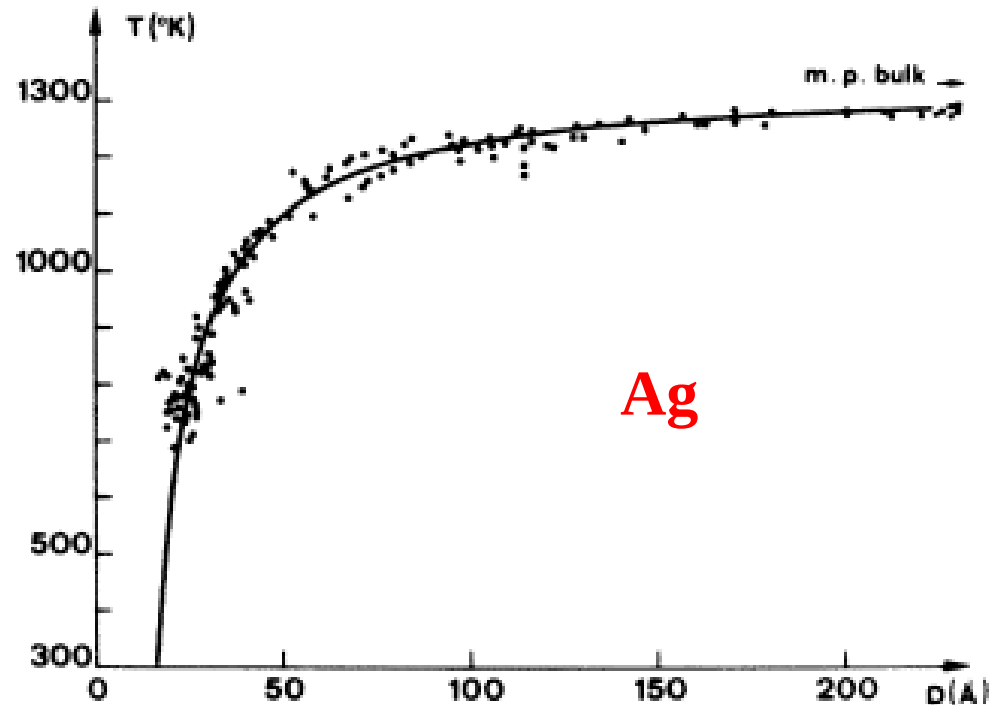


*Five major lessons
that we have learned*

The First Lesson :

Bulk-to-nano Transition

Ex: size-dependence of melting temperature



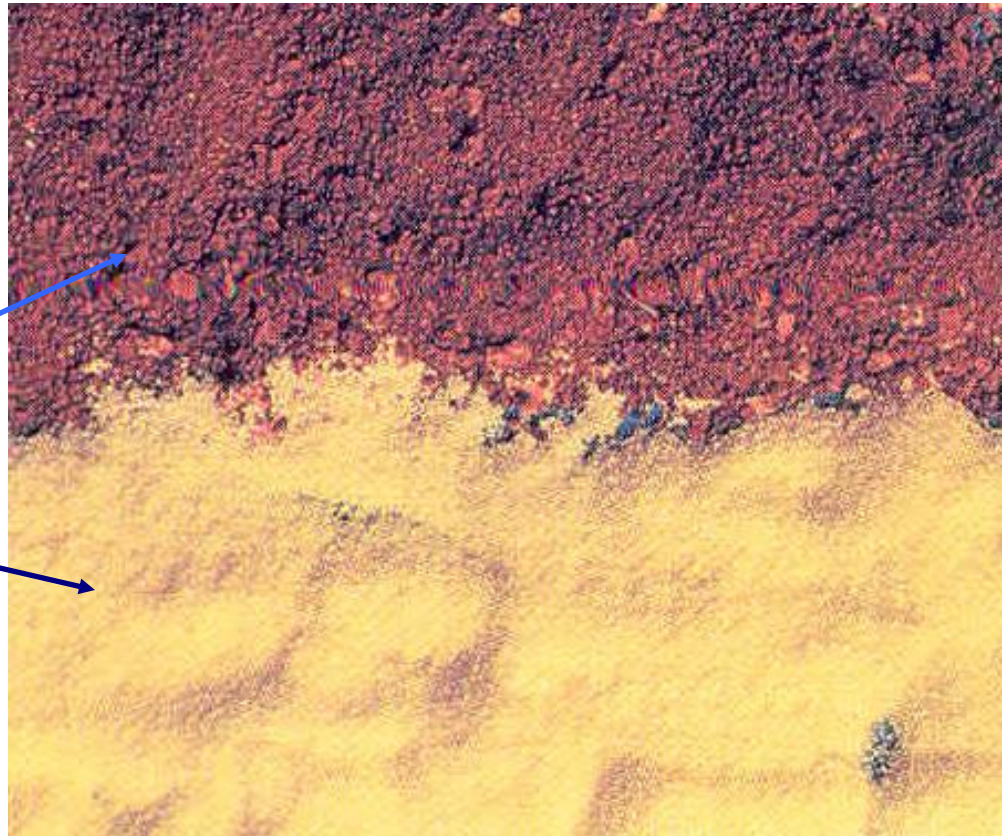
Ph. Buffat and J-P. Borel, Phys. Rev. A13, 2287 (1976)

Ex: size-dependence of color

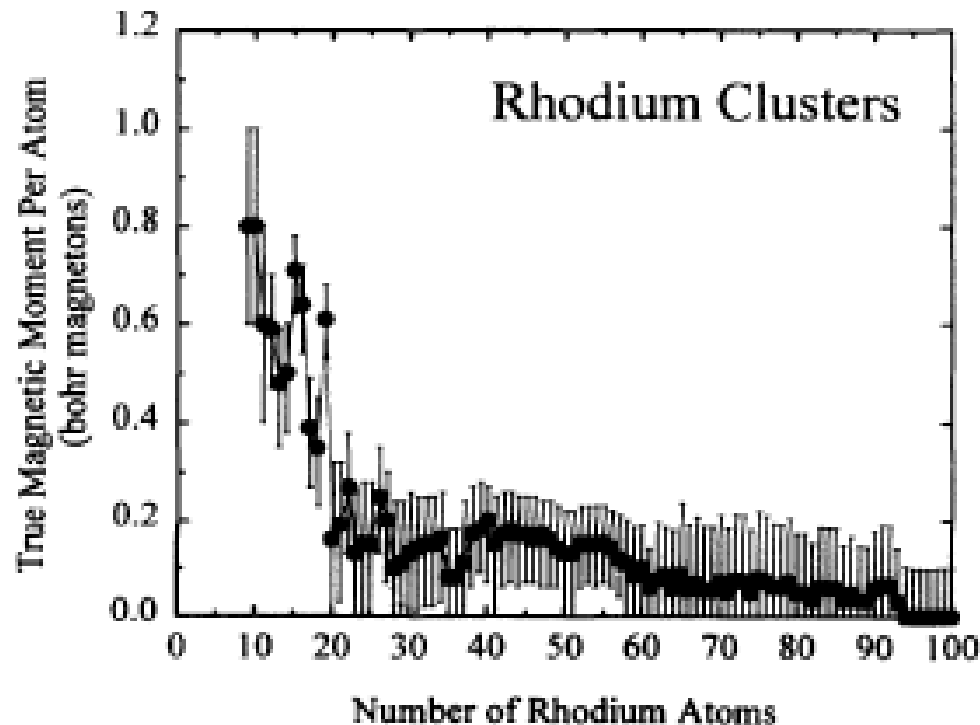
powered cadmium selenide

larger

smaller



Ex: size-dependence of magnetism



A. J. Cox et al. Phys. Rev. B49, 12295 (1994)

The Second Lesson : The Advent of Nano Era

- **The ability of growing the nano scale materials and structures**
- **The ability of detecting and manipulating on the nano scale.**

(I) Advance in thin film growth:

Such as Molecular Beam Epitaxy, atomic layer deposition, laser MBE, etc...

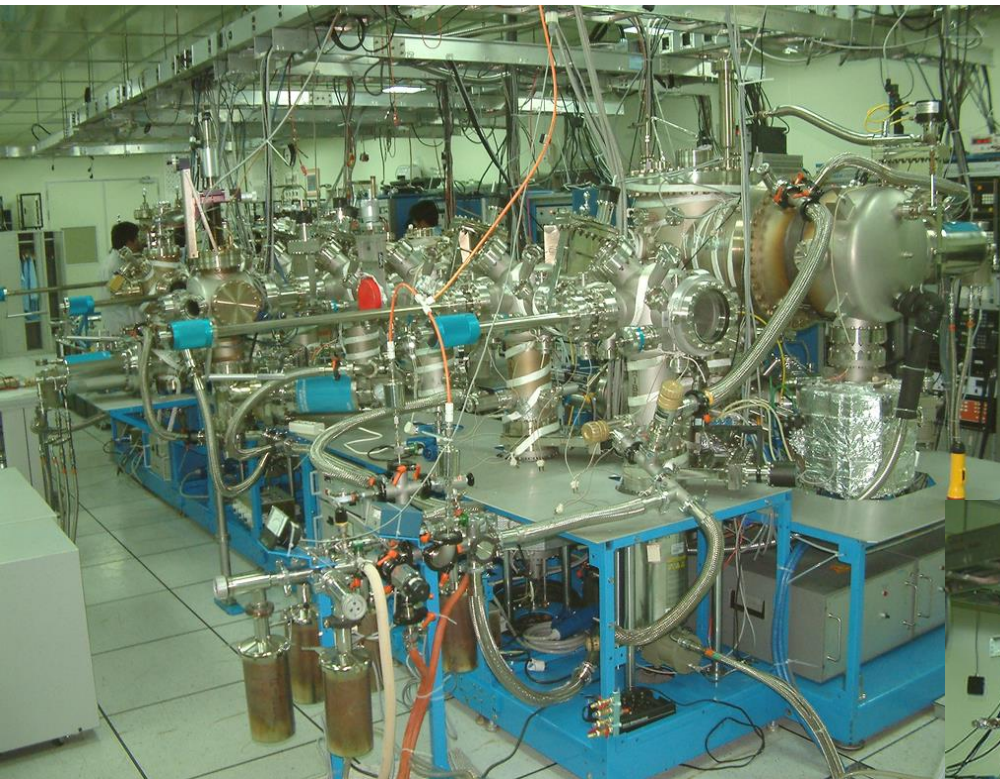
➤ For nano electronics in metals, oxides, and semiconductors

(II) Detection at nano scale : STM, AFM, MFM, STEM, Cs-TEM

➤ In 1982, Binnig, and Rohrer in IBM invented scanning tunneling microscope (STM).

➤ In 1986, Binnig, Quate, and Gerber invented the atomic force microscope (AFM).

Integrated MBE Multi-chamber System



Now located in the Nano
Technology Center, ITRI,
Hsin Chu, Taiwan

**For Metal, Oxide and
Semiconductor Films
On the Nano scale**



Scanning Tunneling Microscope (STM)

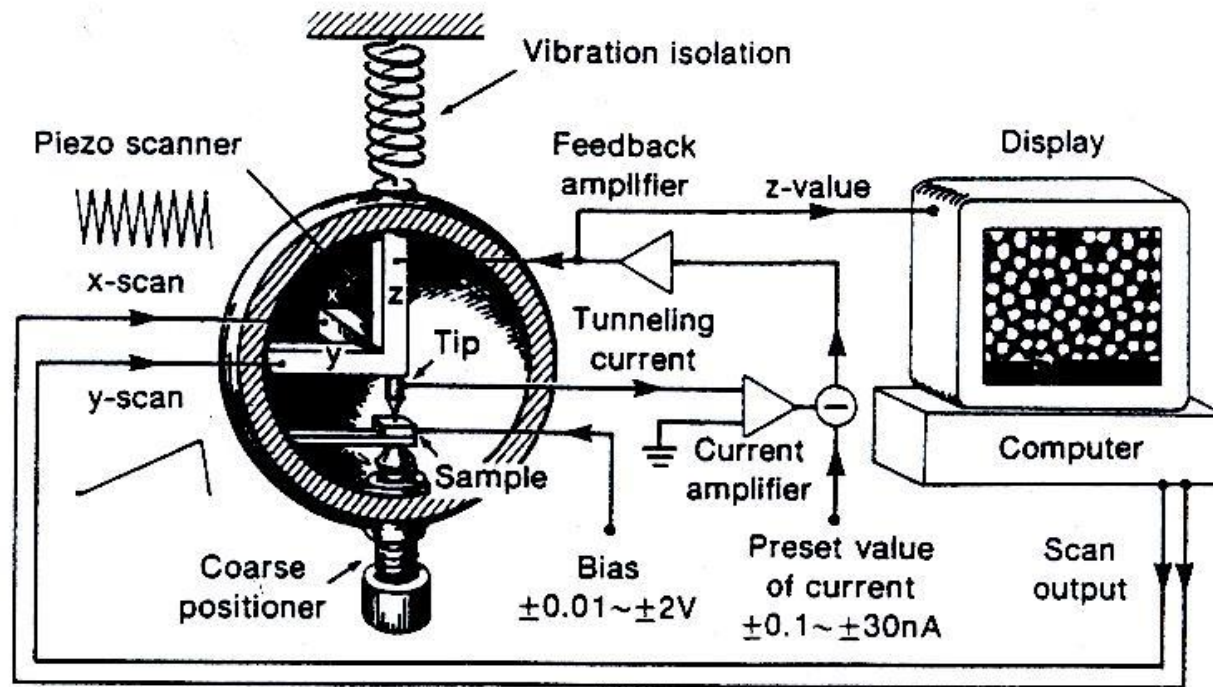
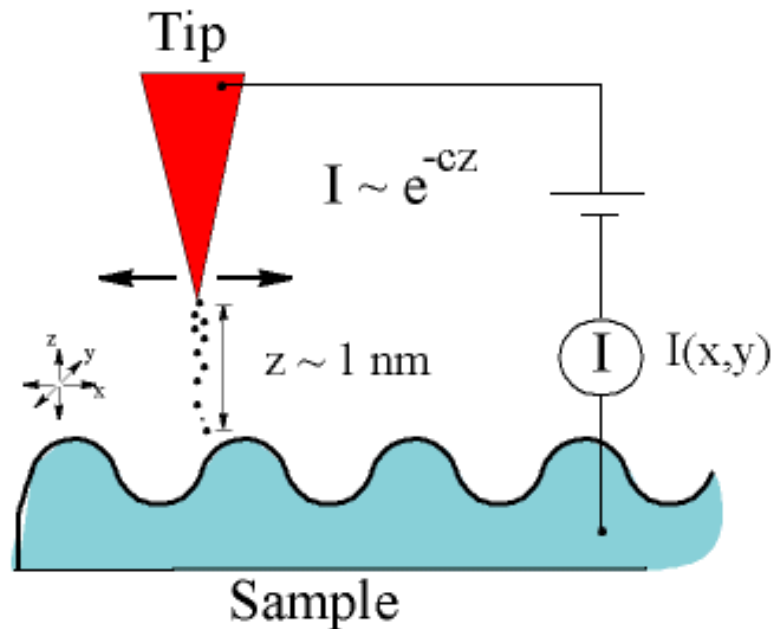
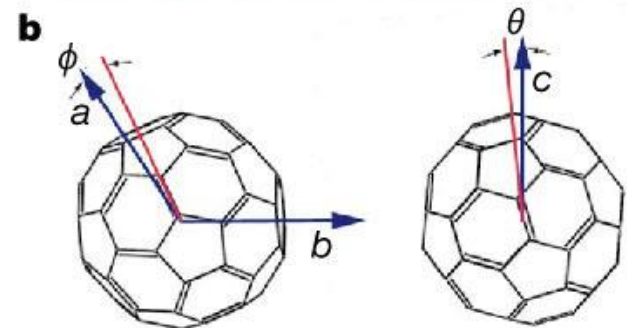
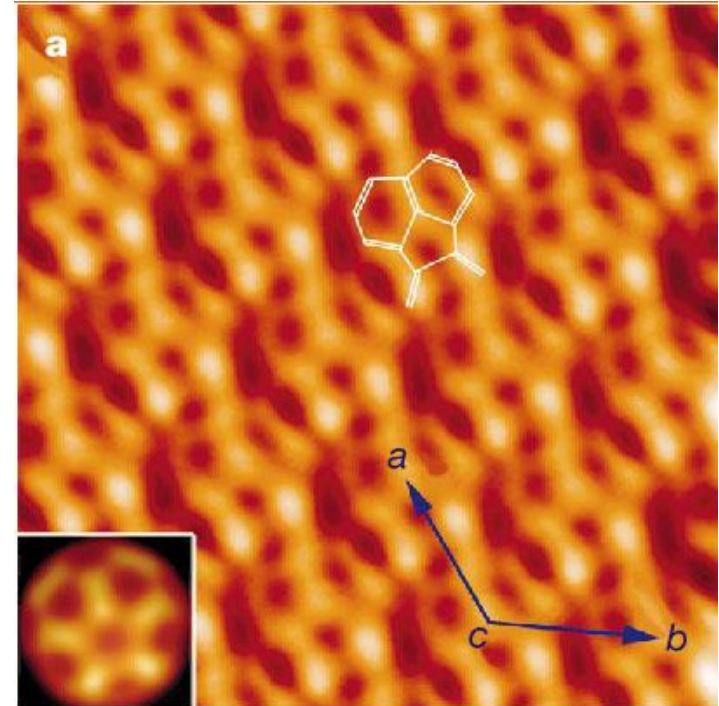


Figure 1.10 Scanning tunneling microscope. (From C. Julian Chen, *Introduction to Scanning Tunneling Microscopy*, Oxford: Oxford University Press, 1993.)

Scanning Tunneling Microscope (STM) – Physicist used to detect nano structures

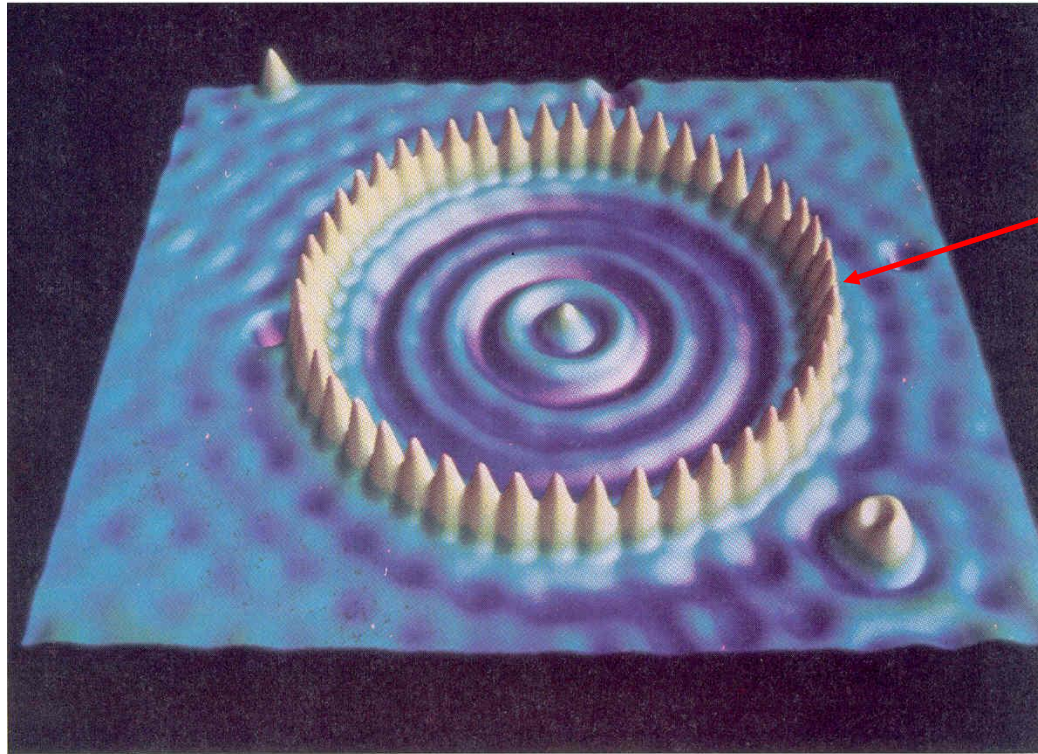


Nature 409, 304 (2001)



Quantum Corral

of 7.13 nm radius, 48 Fe atoms on the Cu (111) surface



Fe

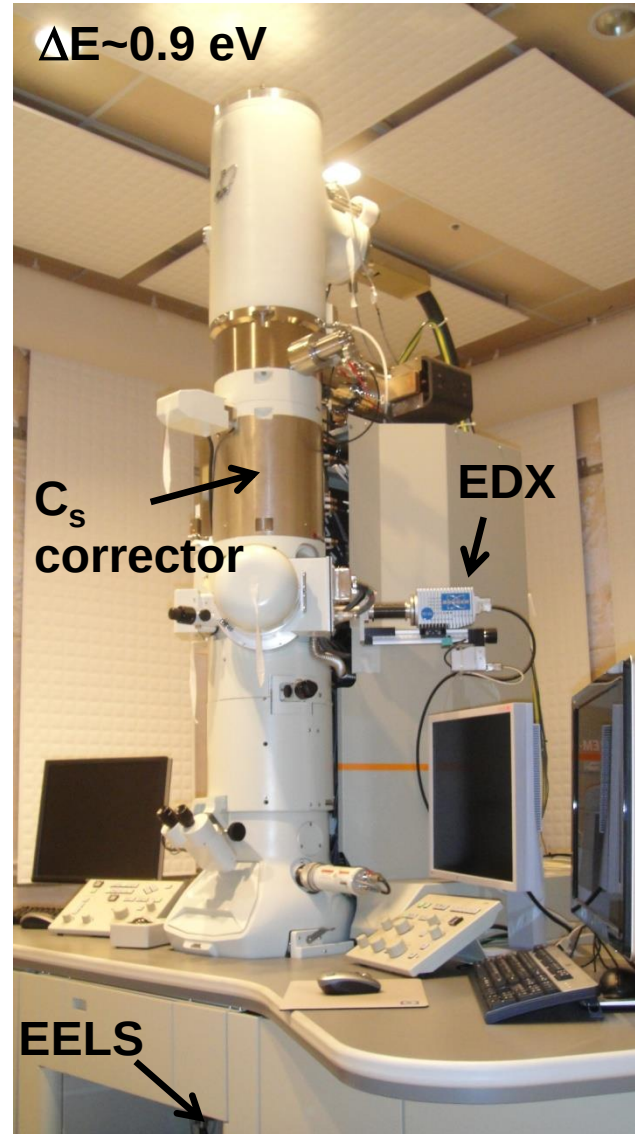
This STM image shows the direct observation of standing-wave patterns in the local density of states of the Cu(111) surface. These spatial oscillations are quantum mechanical interference patterns caused by scattering of the 2D electron gas off the Fe adatoms and point defects.

Scanning Transmission Electron Microscope Laboratory

2-Å STEM



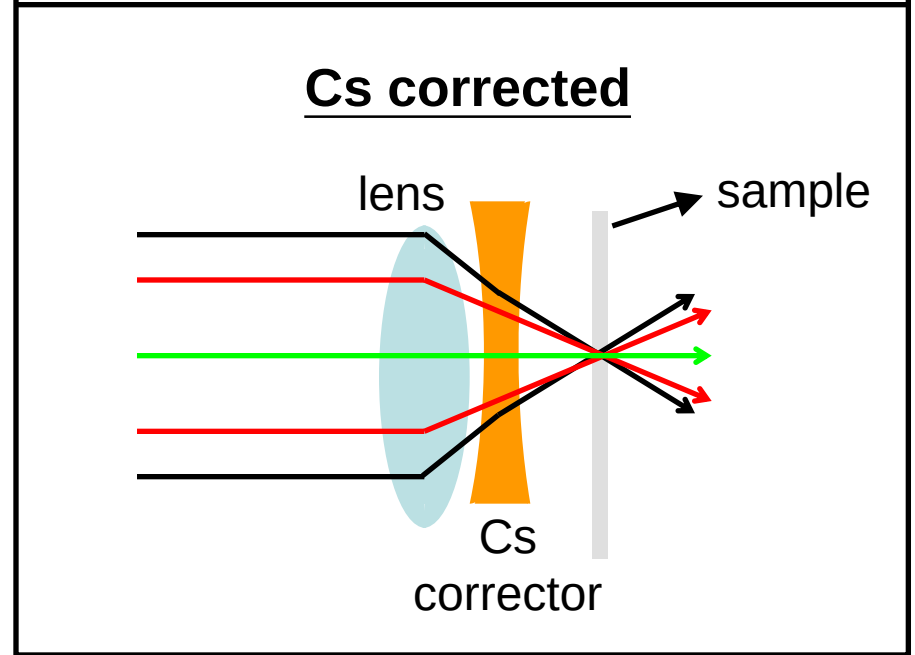
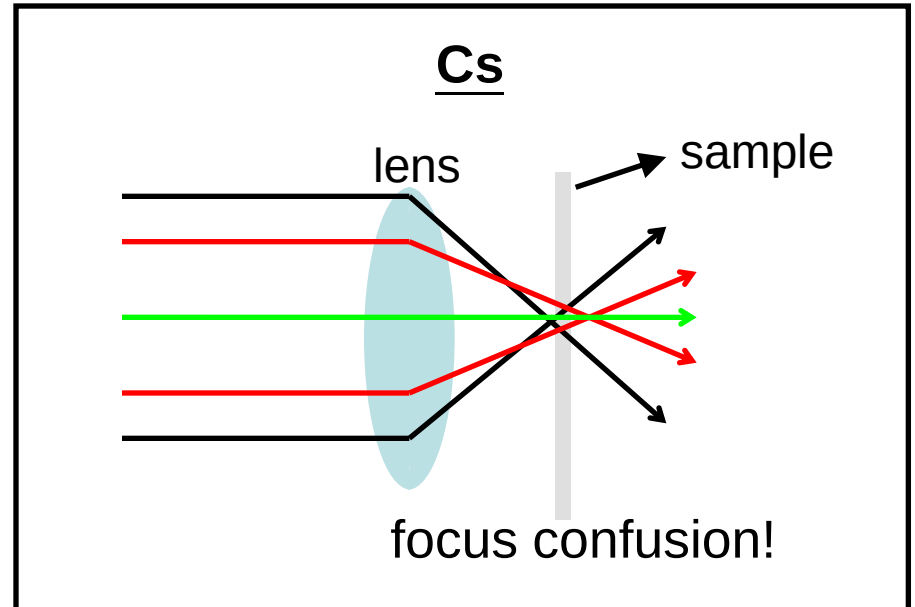
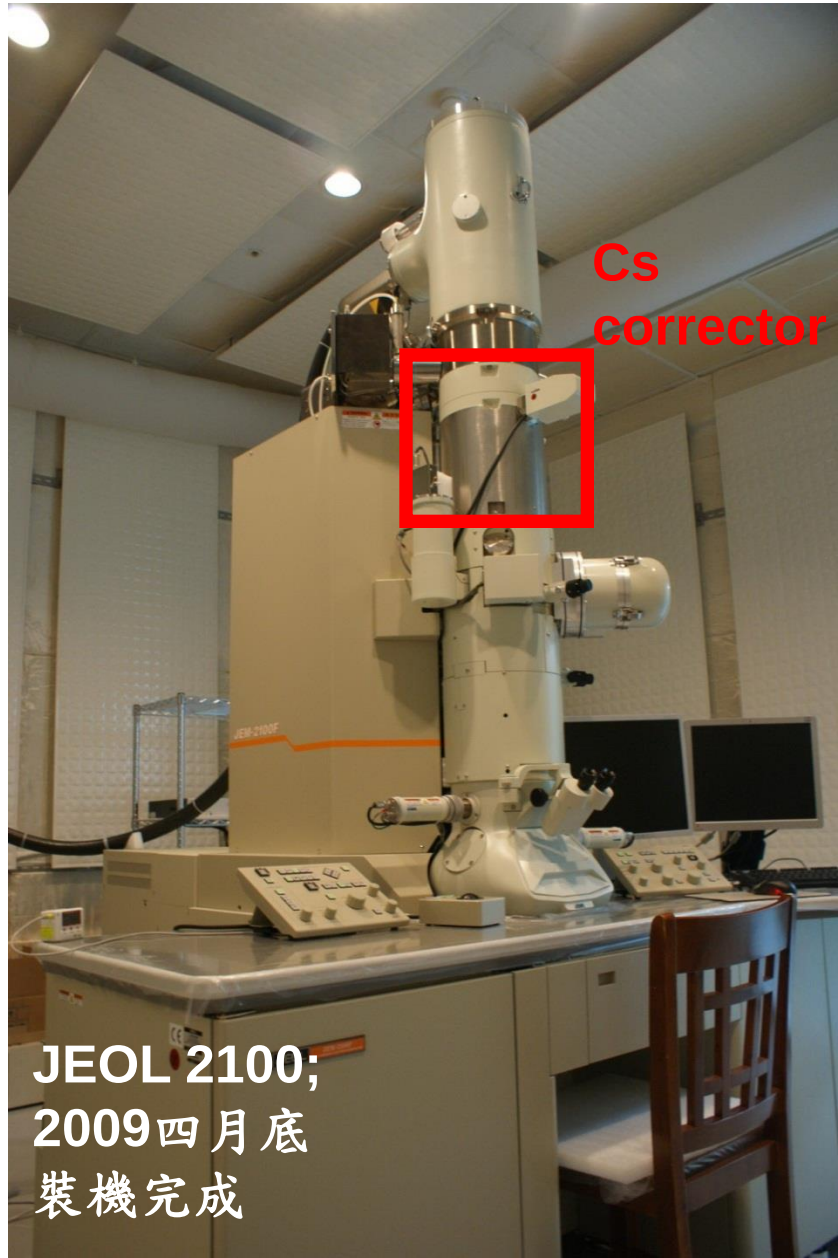
1-Å STEM



Prof. C. H. Chen and
Dr. M.-W. Chu
In CCMS/NTU.

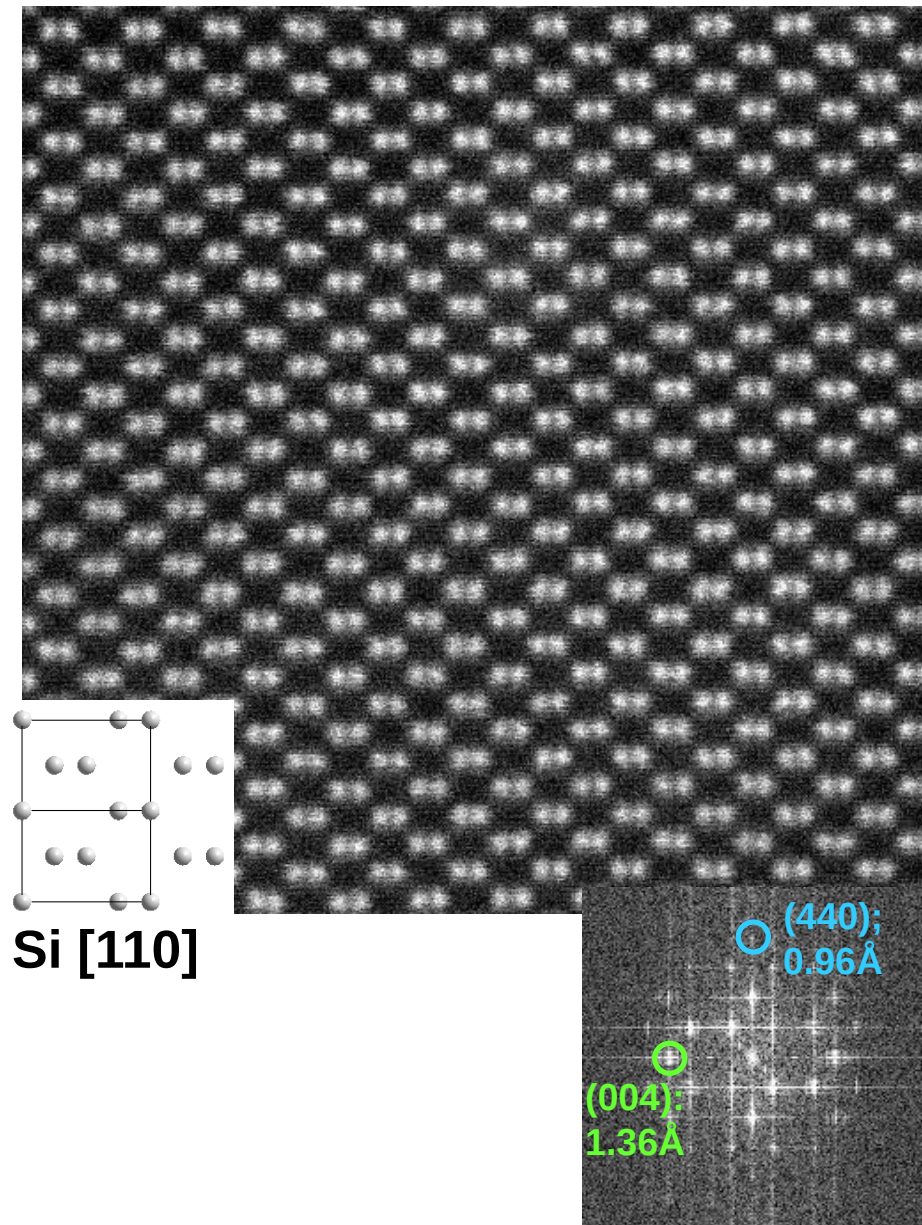
Spherical Aberration Corrected (球面相差)

Cs-STEM by C. H. Chen at CCMS, NTU

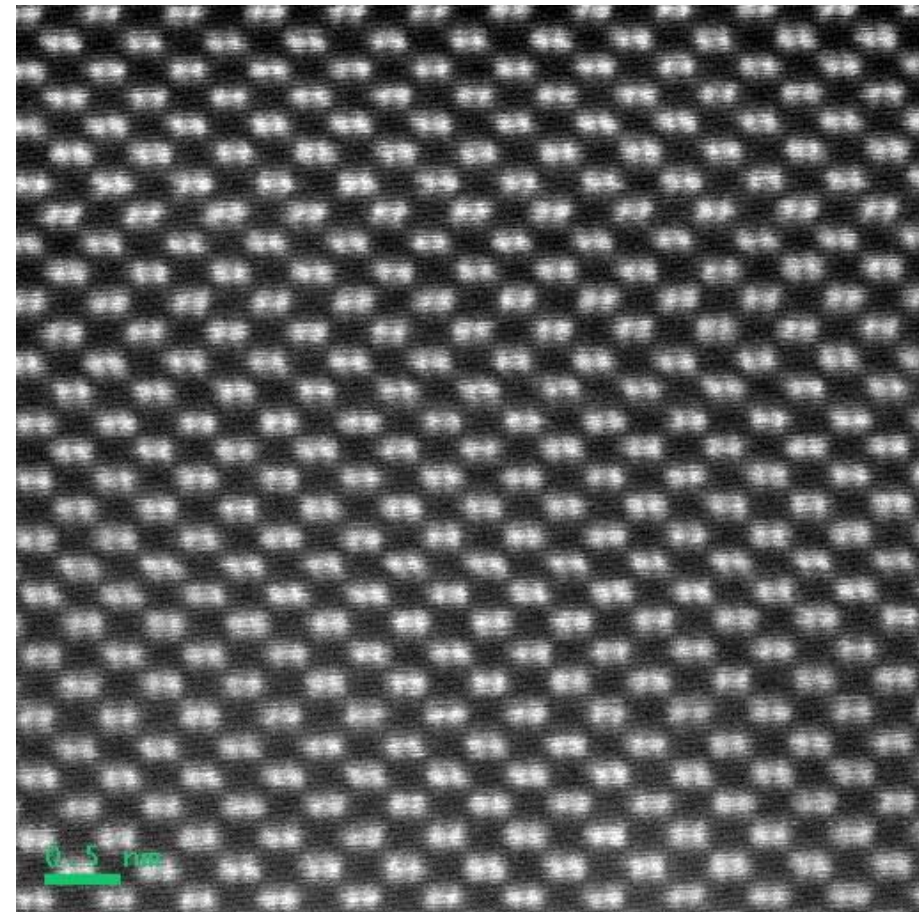


High-Angle ADF: Si dumbbell, 1.36 Å spacing

15s exposure

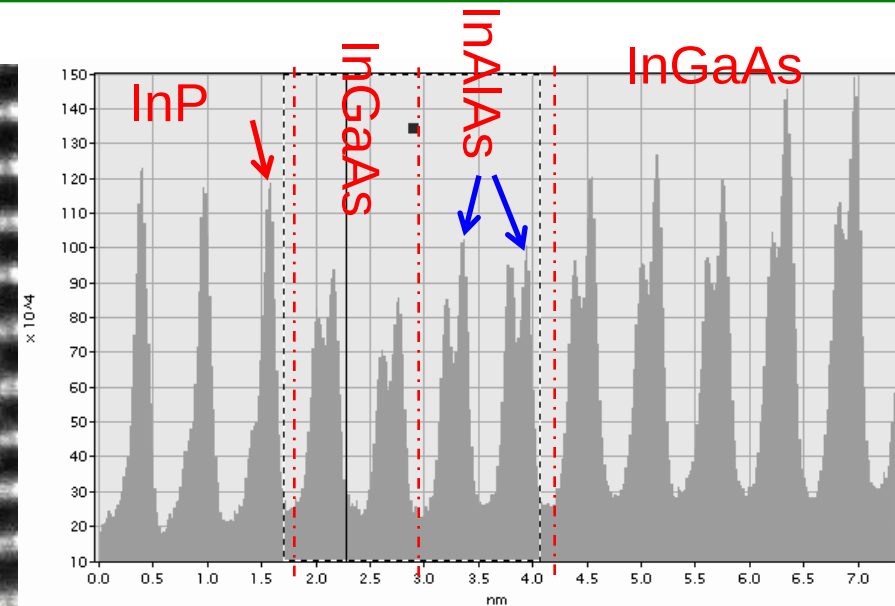
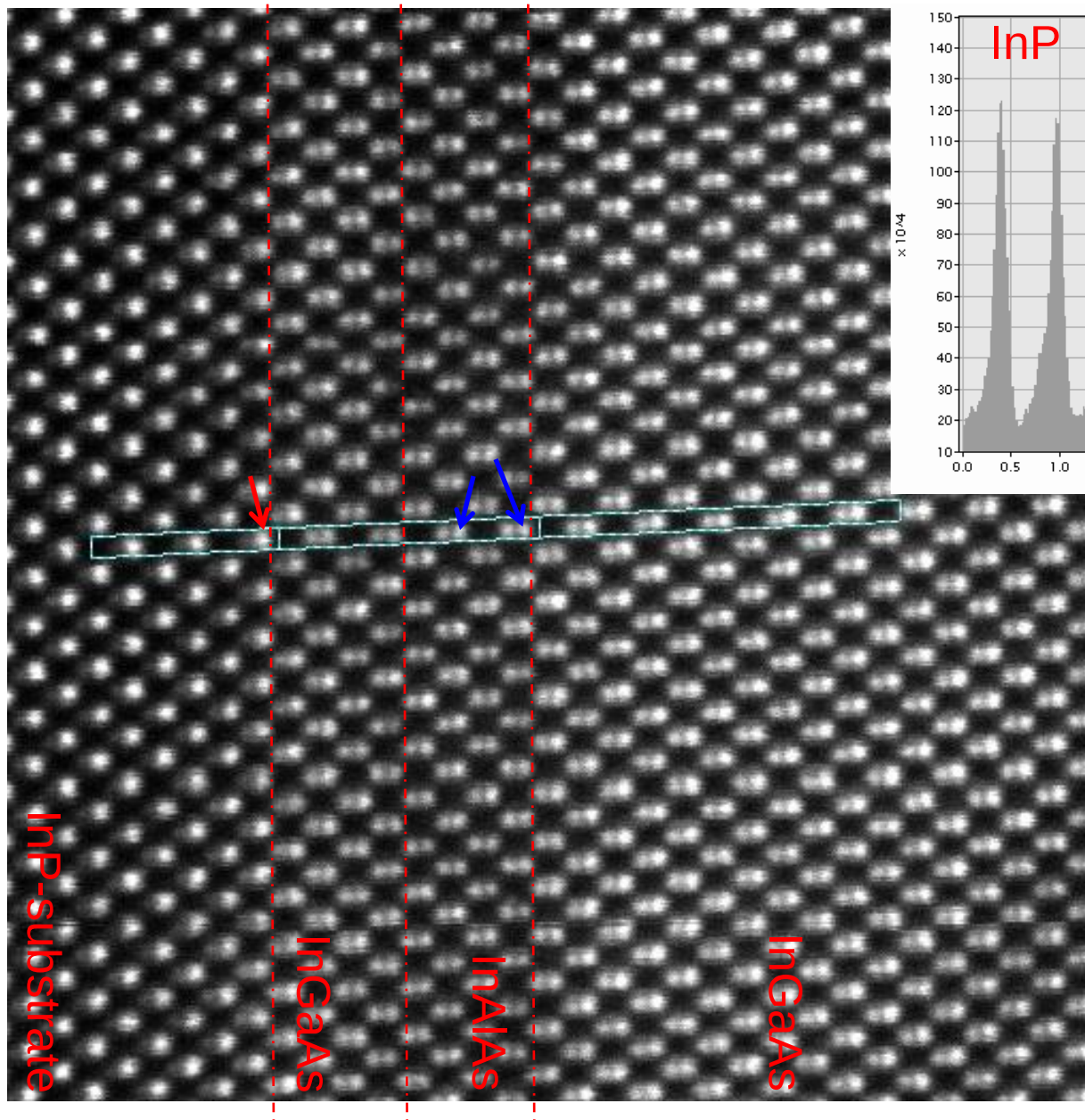


60s exposure



Drift ~1Å/min !!

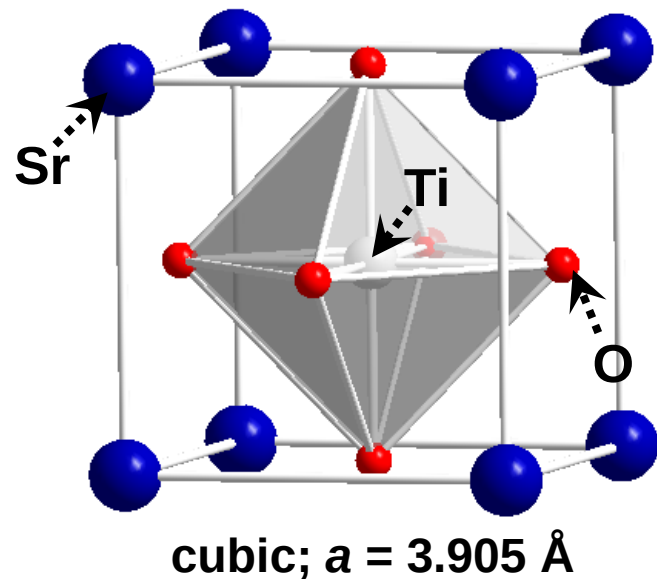
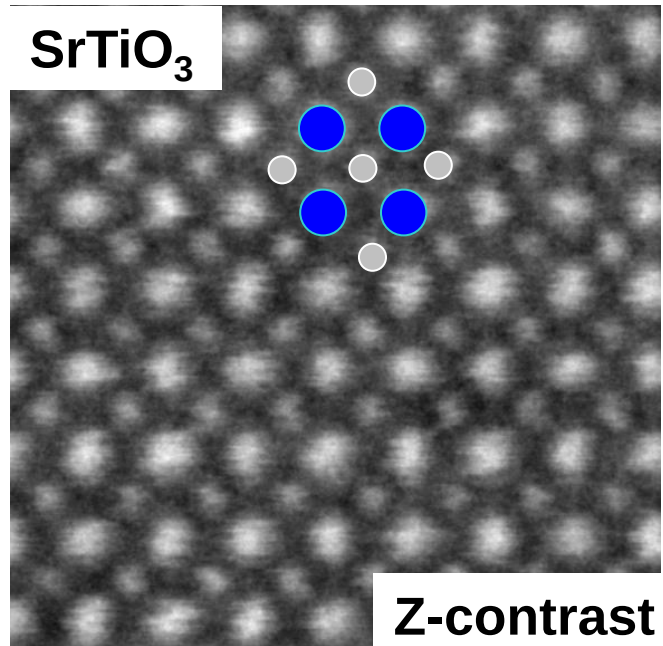
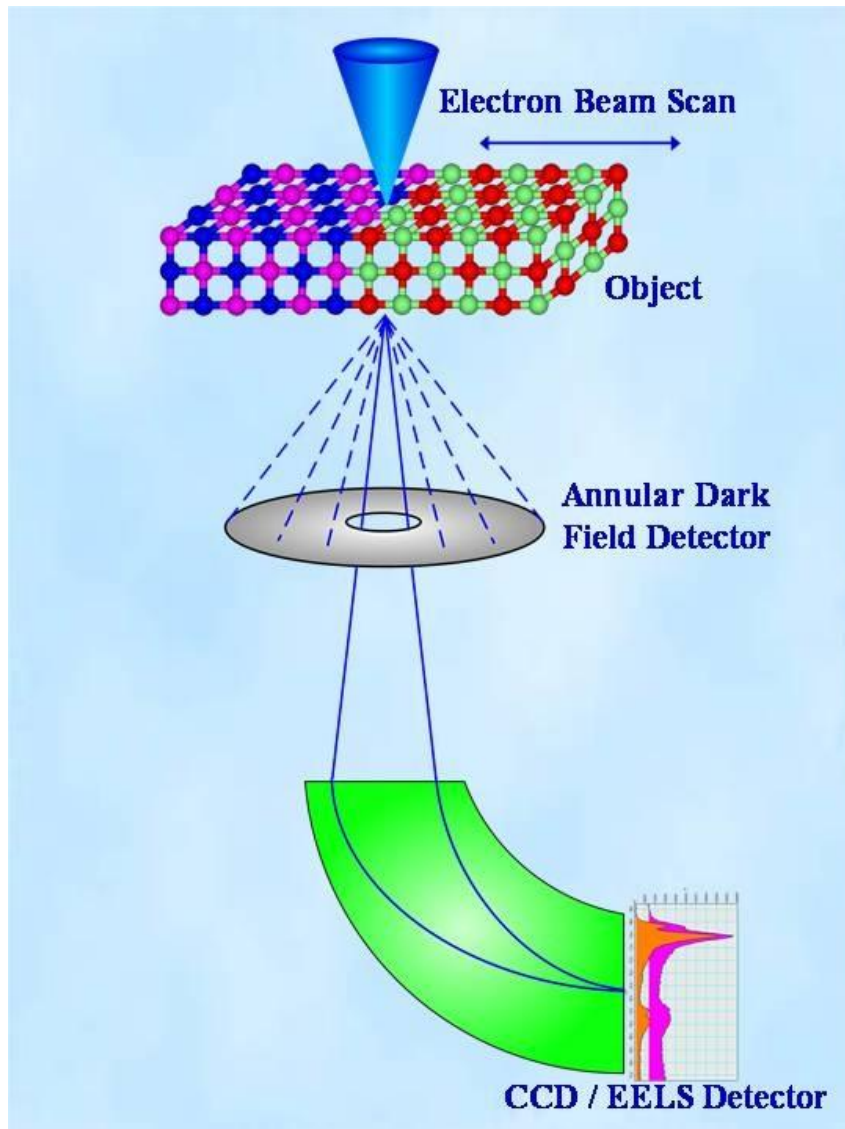
InGaAs/InAlAs superlattices on InP Substrate



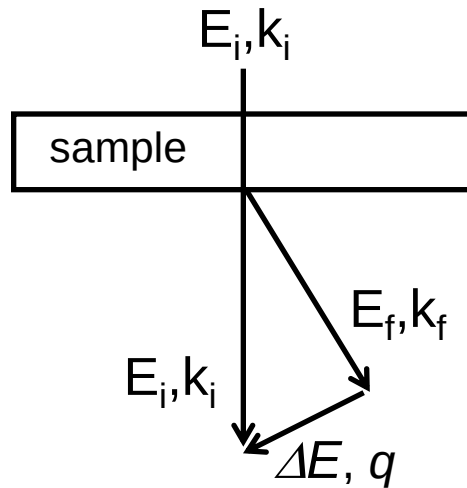
- Determining the interface location and sharpness is easy.
- The In-distribution seems to be inhomogeneous in the InAlAs layer (blue arrows).
- Note that InP substrate is In-terminated (red arrow).

Atomic Resolution STEM Imaging: Z-contrast

2-Å Electron Probe



Electronic Exc.: Electron Energy-Loss Spectroscopy (EELS)



$$\Delta E = E_i - E_f$$

$$q = k_i - k_f$$

Coulomb Interaction

$$v(r) = \sum_j \frac{e^2}{|r - r_j|}$$

$$= \sum_q v_q \rho_q e^{iqr}$$

, where ρ_q the electron density operator



Inelastic Scattering (ΔE) Probability

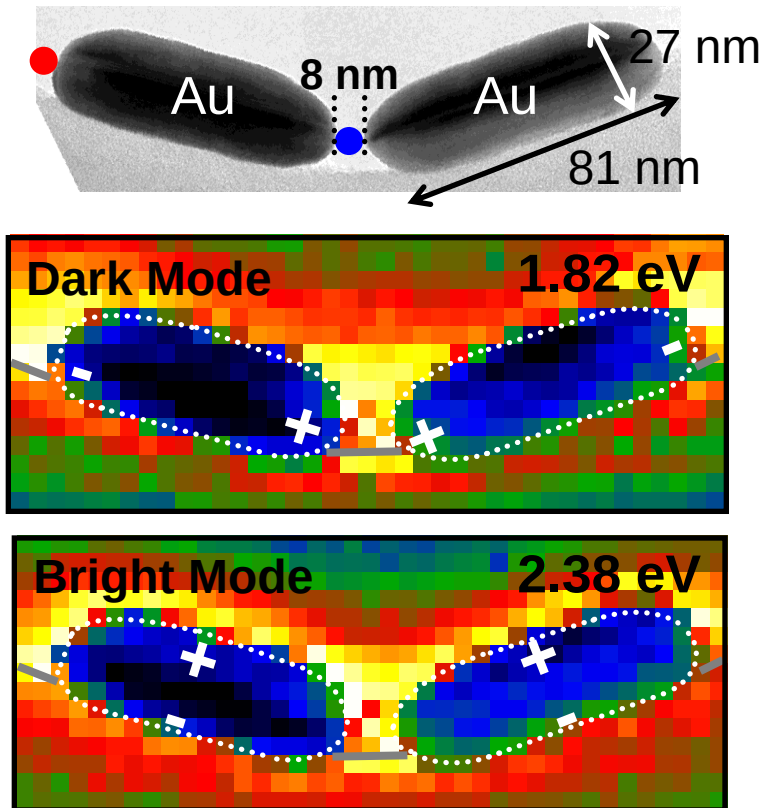
$$\frac{d^2\sigma}{d\Omega d\omega dE} \sim \sum_f \left| \langle \psi_f | v(q) | \psi_i \rangle \right|^2 \delta(E_i - E_f - \Delta E)$$

$$\sim \frac{1}{q^4} \cdot S(\omega, q) \quad \longrightarrow \quad \text{X-ray}$$

$$\sim \frac{1}{q^2} \cdot \text{Im} \left[\frac{1}{\varepsilon(\omega, q)} \right] \quad \longrightarrow \quad \text{EELS}$$

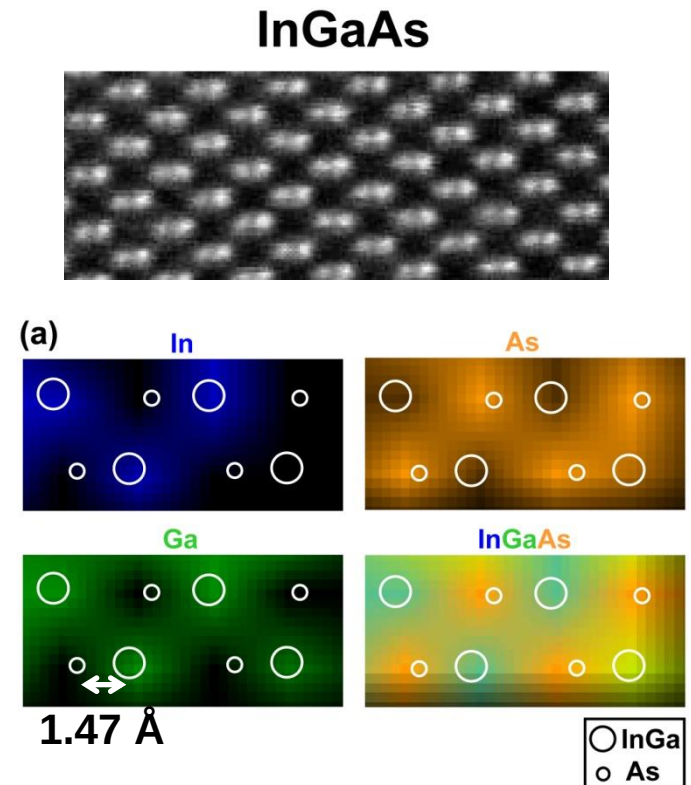
Spectral Imaging at Ultimate Spatial Resolution

Plasmonic Mapping: STEM-EELS (2-Å Probe)



M.-W. Chu *et al.*, Nano Lett. **9**, 399 (2009).

Chemical Mapping: STEM-EDX (1-Å Probe)



M.-W. Chu *et al.*, Phys. Rev. Lett. **104**, 196101 (2010).

The Third Lesson:

**The importance of
Quantum Physics**

The cause for variation of scaling

- Influence of Boundary
 - Increase of proportion of boundaries
 - Existence of surface / edge modes
 - Geometrical reconstruction
- Decrease of the number of particles
decrease of confinement , increase of perturbation
- Different scaling for different physical entity

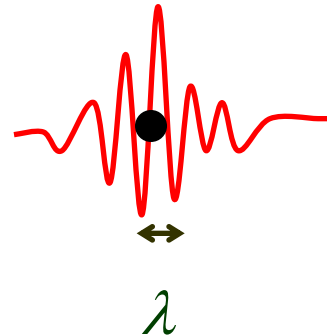
Quantum Effect:

=> Most likely to have new breakthrough !

The connection of materials wave with mechanics

h = Planck constant
(6.626×10^{-34} joule-sec)

DeBroglie:
 $\lambda = h/p$



Einstein:
 $E = h\nu = p^2/2m$

Wave length

Free electrons

$$\lambda_{th}(300K) = 6.2nm$$

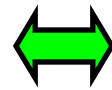
Semiconductors

$$10nm \leq \lambda \leq 100nm$$

Atoms

$$(300K) \leq 0.2nm$$

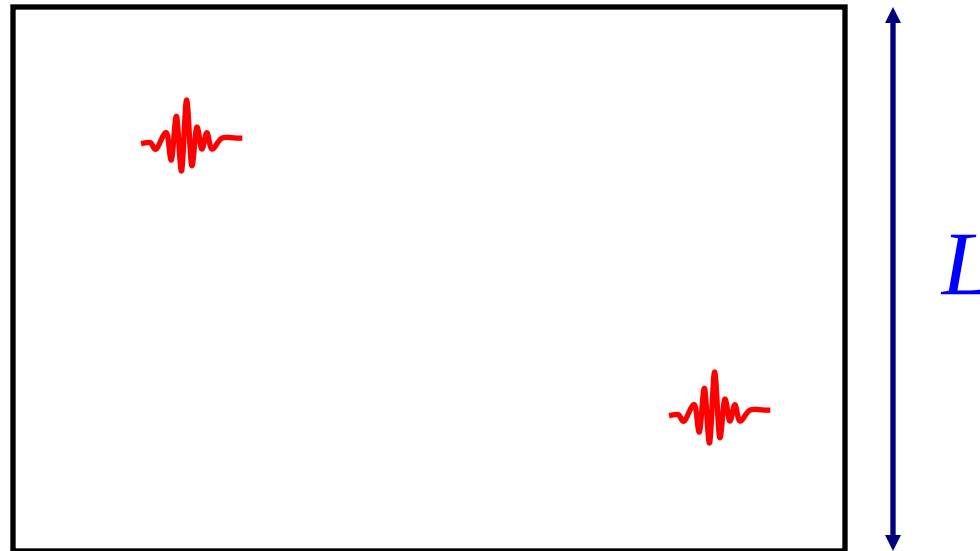
Bulk Limit



Nano Limit

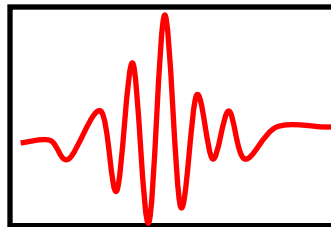
**Bulk
materials**

$$\lambda \ll L$$



Nano

$$\lambda \sim L$$



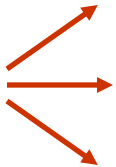
Major Quantum Effect at the nano scale

- Interference
- Quantization
- Tunneling
- Quantum Spin

(I) Interference

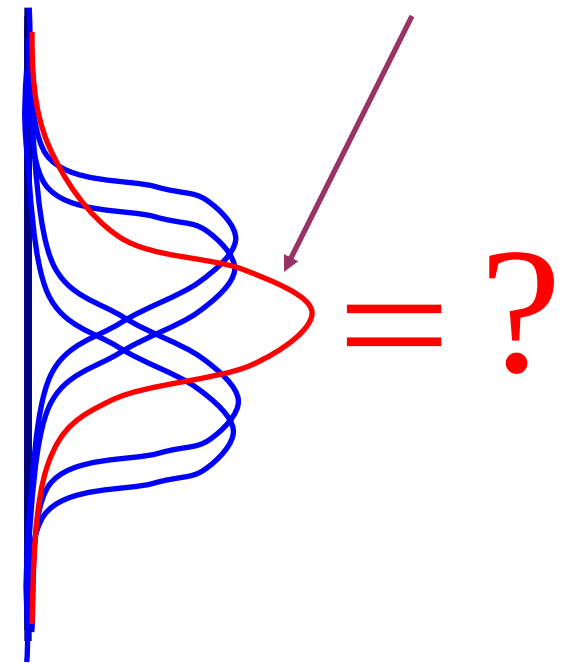
The wonder of electron in waves

Electron source

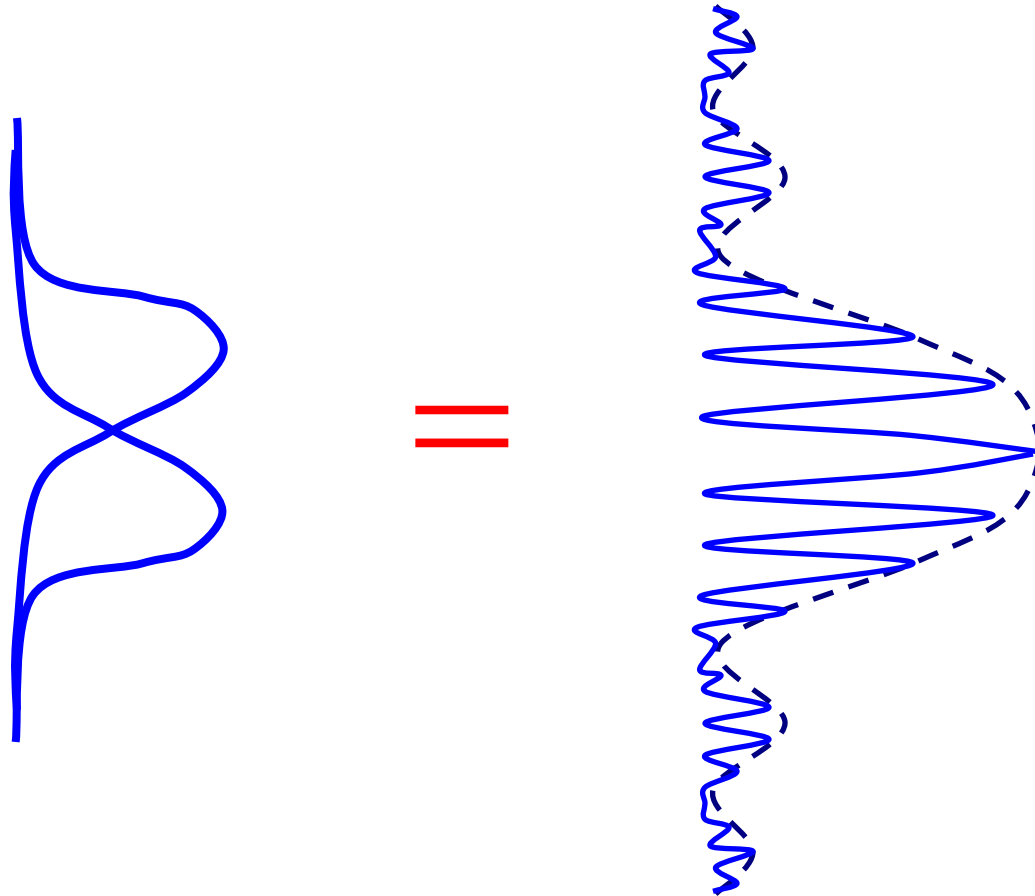


A diagram showing an 'Electron source' on the left with three orange arrows pointing right towards a vertical blue line representing a barrier.

Classical mechanics

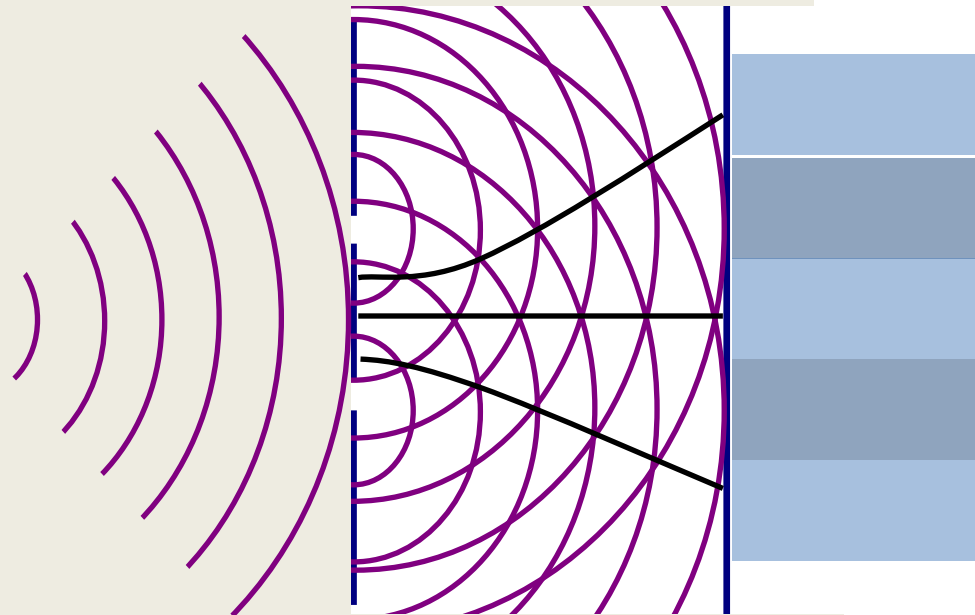


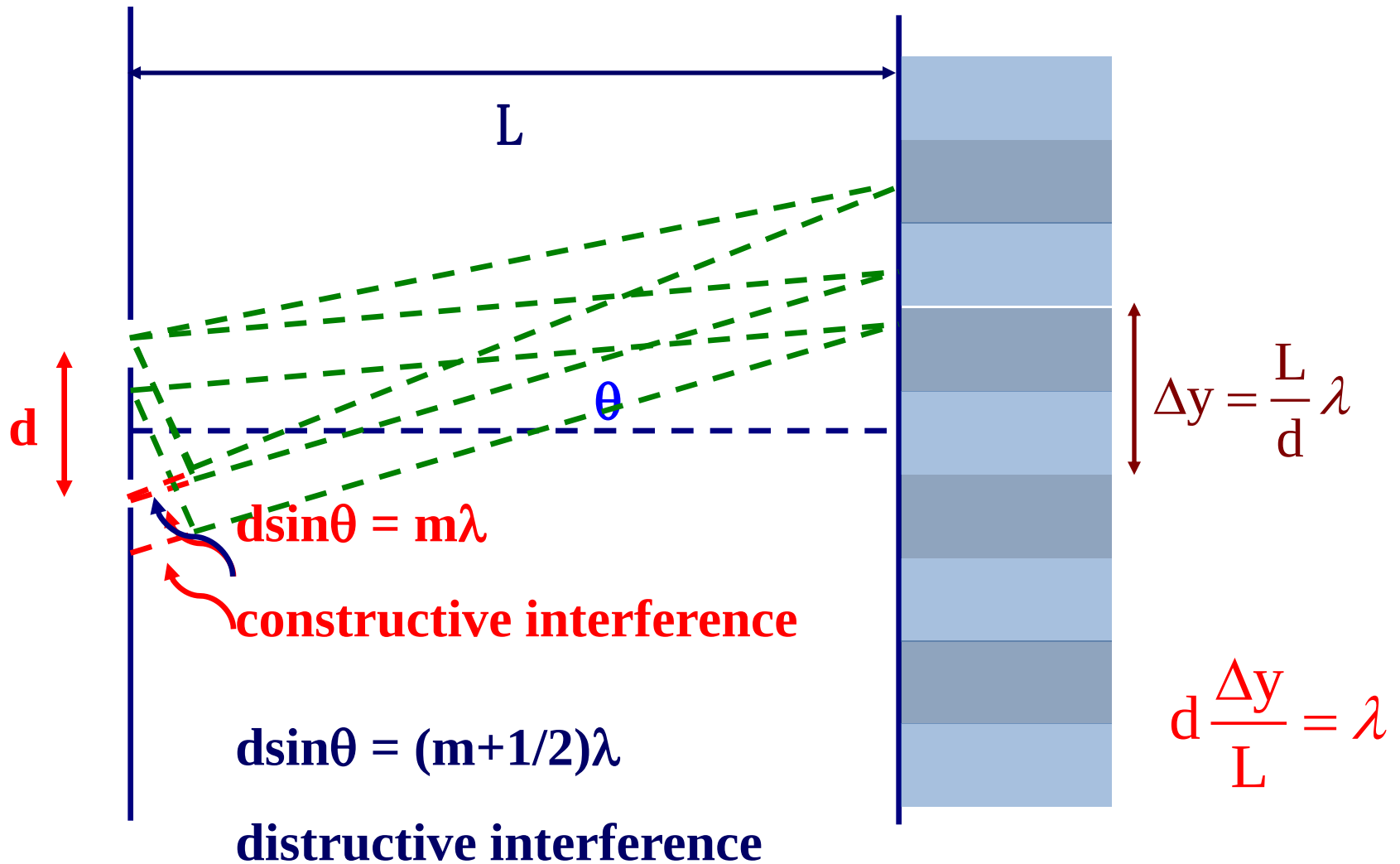
The wave property of electrons



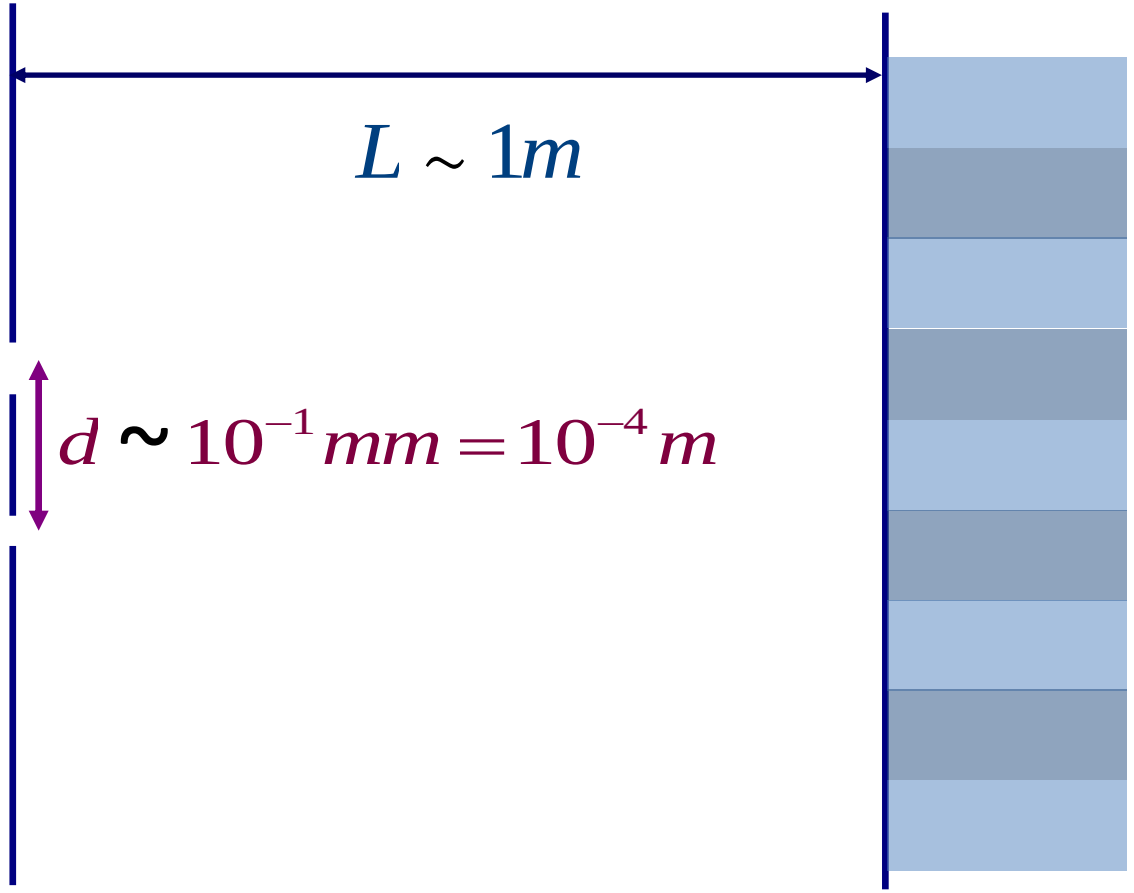
Double Slit Interference of Electrons

Electron source





~


$$L \sim 1m$$

$$\lambda \sim 700nm$$

$$\lambda \sim 0.17nm$$

$$d \sim 10^{-1}mm = 10^{-4}m$$

$$\Delta y = \frac{L}{d} \lambda$$
$$= 7mm$$

$$\Delta y = 1.7\mu m$$

(II) Quantization

Confinement of the materials wave



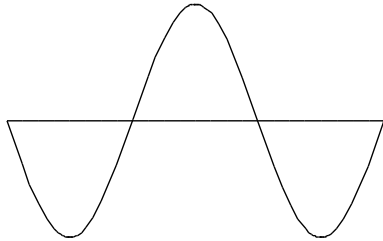
Standing Wave



Quantizations

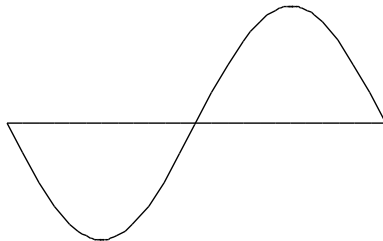
The Quantization of Energy

$n = 3$



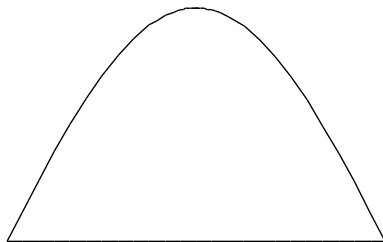
$$L = \frac{n}{2} \lambda$$

$n = 2$



$$p = \frac{h}{\lambda} = \frac{nh}{2L}$$

$n = 1$



$$\Delta E \propto 1/L^2$$

$$E_n = \frac{p^2}{2m} = \frac{n^2 h^2}{8mL^2}$$

L

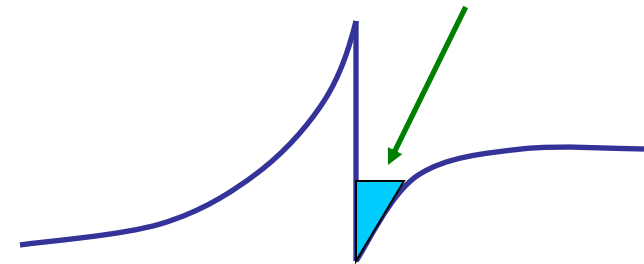
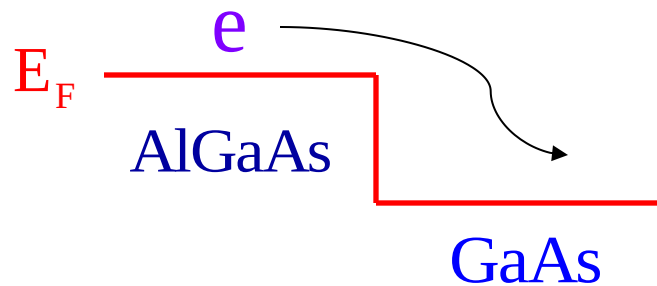
Quantum well: 1D confinement

MOSFET:

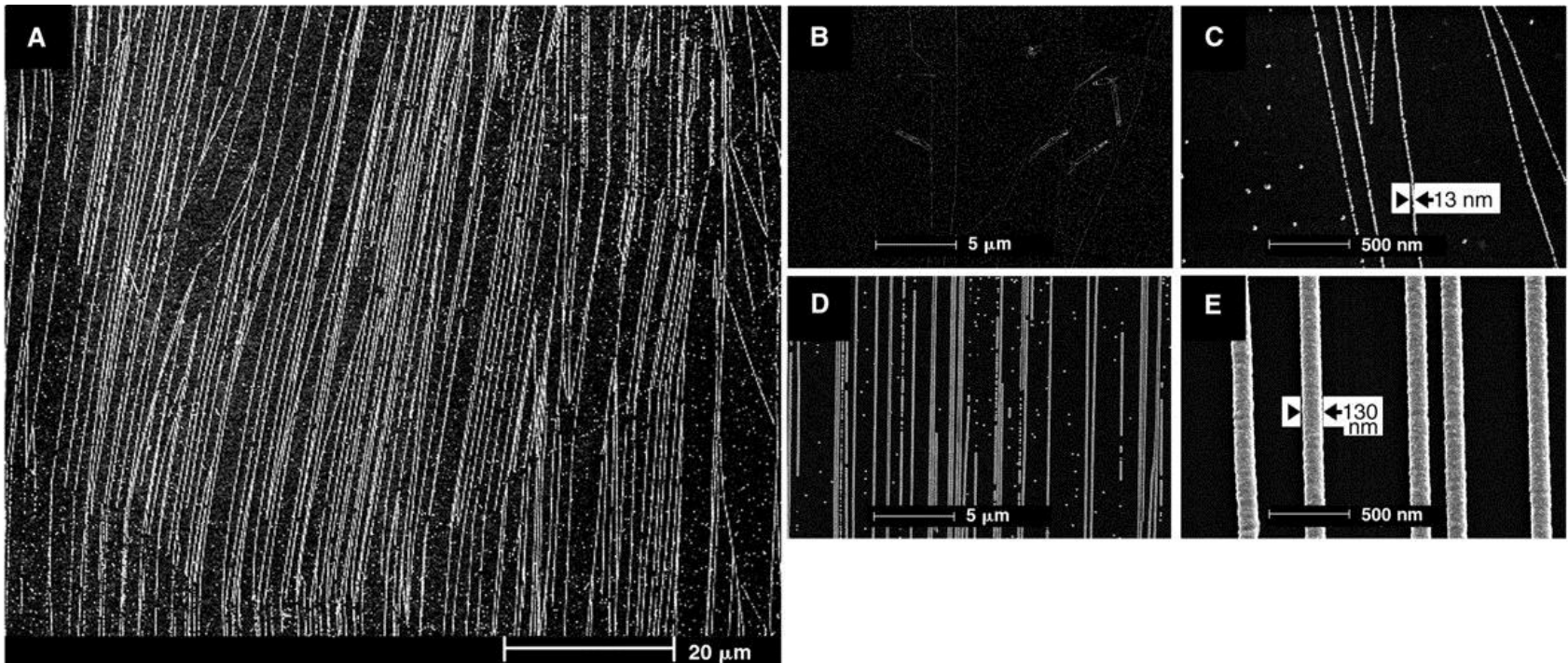


2D electron Gas

二維電子氣

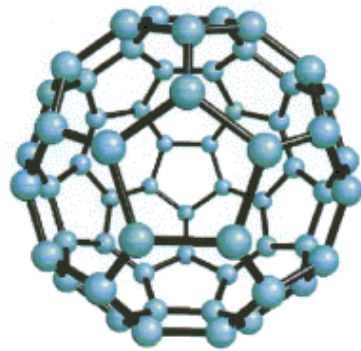


Quantum wire: 2 D-Confinement

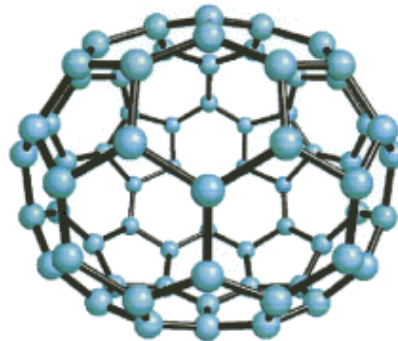


SEM images of MoO_x nanowires on graphite surfaces
Science **290**, 2120-2123, (2000)

Quantum dot: 3 D - Confinement

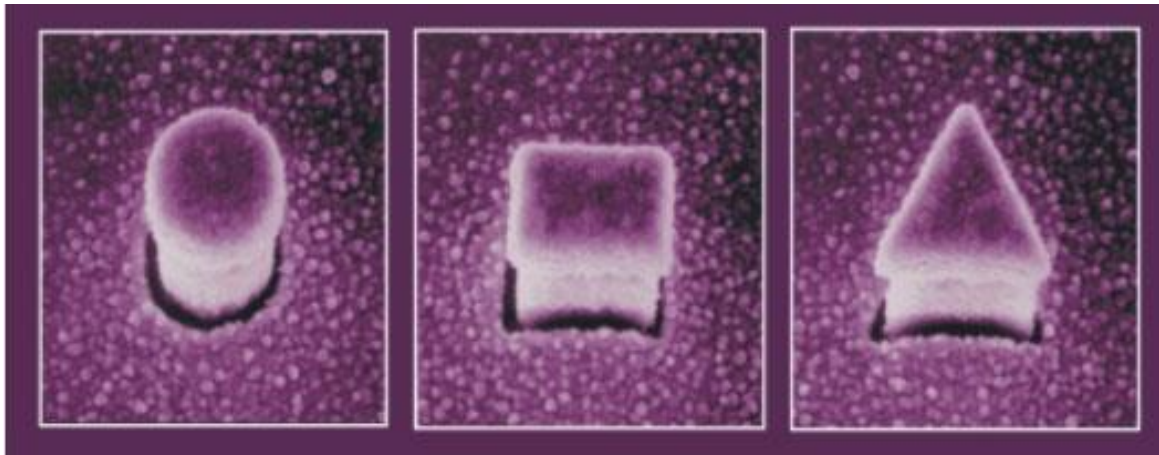
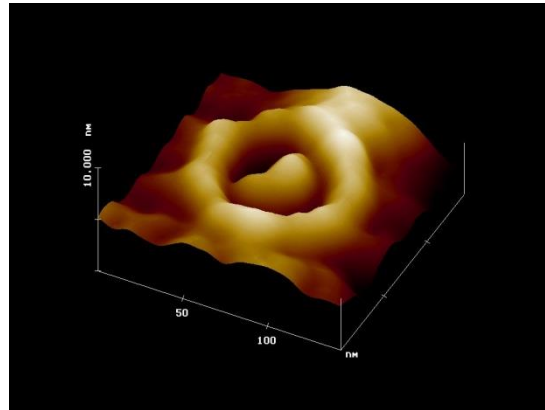


C_{60}



C_{70}

Quantum Dots of various shape



Absorption in scattering
From red to yellow



A diagram showing seven horizontal blue lines representing energy levels. To the right of the lines, a vertical double-headed blue arrow is labeled with the Greek letter λ . To the right of the arrow, the equation $E = hc / \lambda \propto 1 / L^2$ is written in black.

$$E = hc / \lambda \propto 1 / L^2$$

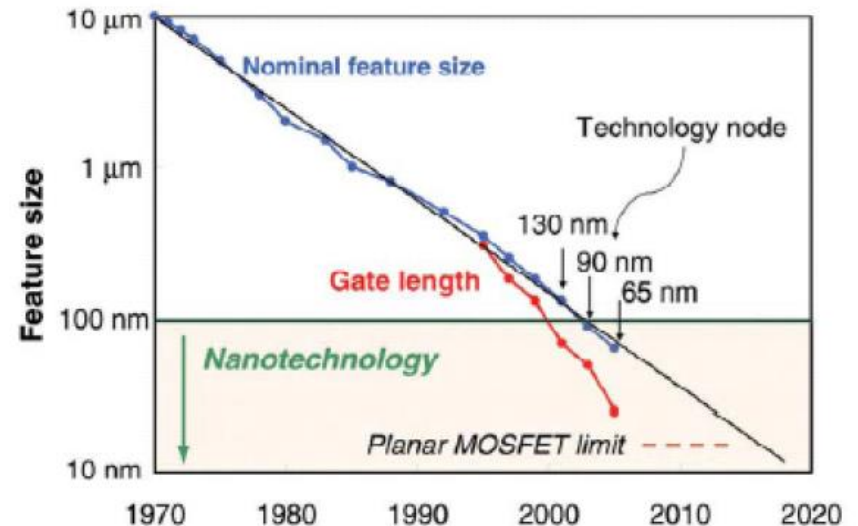
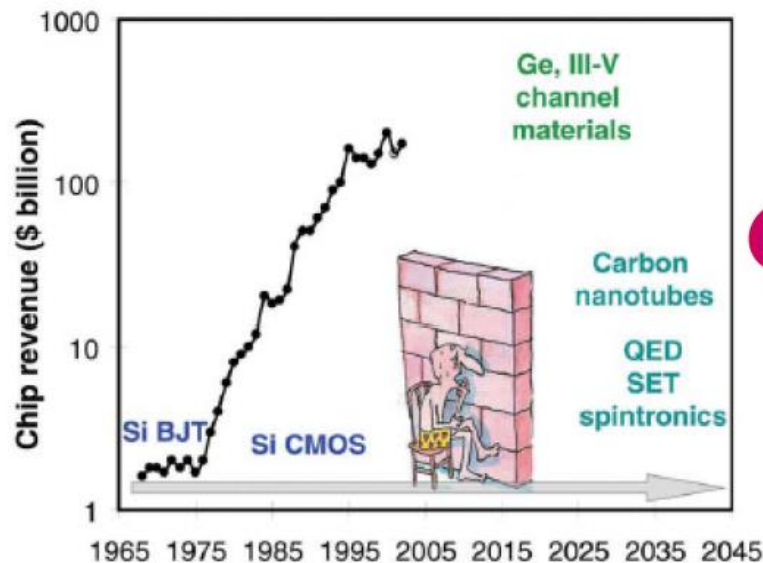
powdered Cadmium Selenide

larger
smaller



Background for search new platform

Scaling limit of Si MOSFET & superparamagnetism



Carbon era?

Thompson and Parthasarathy,
Materialstoday 9, 20, 2006